



JF

Our Ref. No.: 42390P4214DC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application for:

Chunlin Liang, Brian S. Doyle

Serial No.: 10/632,578

Filed: July 31, 2003

For: **A THERMAL CONDUCTING
TRENCH IN A SEMICONDUCTOR
STRUCTURE AND METHOD FOR
FORMING THE SAME**

Examiner: Thanh V. Pham

Art Group: 2823

Confirmation No. 5026

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Examiner:

In response to the Office Action dated June 28, 2004, Applicants respectfully request entry of the amendment set forth below and consideration of the remarks that follow.